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APPLICANTS Hiroaki Himi, Nagoya-city, JAPAN; Noriyuki Iwamori, Okazaki-city, JAPAN; ** CONTINUING DATA ***** <i>yes TSP</i> This application is a DIV of 09/713,018 11/16/2000 PAT 6,676,748 ** FOREIGN APPLICATIONS ***** <i>yes CRP</i> JAPAN 11-326934 11/17/1999 JAPAN 2000-333286 10/31/2000				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/01/2004				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>TSP</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 11	TOTAL CLAIMS 20
				INDEPENDENT CLAIMS 6
ADDRESS 23400				
TITLE Method for manufacturing semiconductor substrate				
FILING FEE RECEIVED 1128	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	